

Docket No.: L&L-I0078

1762

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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applic. No. : 09/939,330
Applicant : Alfred Kersch et al.
Filed : August 24, 2001
Art Unit : 1762
Examiner : Eric B Fuller

Confirmation No: 3872

Docket No. : L&L-I0078
Customer No. : 24131

INFORMATION DISCLOSURE STATEMENT
UNDER 37 C.F.R. 1.97(C)(1)

Hon. Commissioner for Patents

Sir:

In accordance with 37 C.F.R. 1.98 copies of the following patents and/or publications are submitted herewith:

United States Patent No. 5,104,690 (Greenwald), dated April 14, 1992;

United States Patent No. 5,753,300 (Wessels et al.), dated May 19, 1998;

Japanese Patent Abstracts JP 60 026 663 (Yano), dated February 9, 1985;

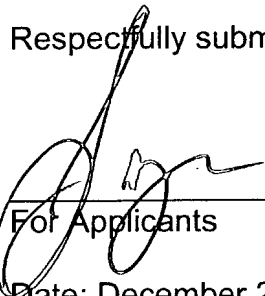
L.A. Wills et al.: "Deposition of Ferroelectric $\text{Bi}_4\text{Ti}_3\text{O}_{12}$ Thin Films", *Extended Abstracts, Fall Meeting, Seattle, Washington, 90/2, 1990, p. 701, Princeton, NJ, XP-000294124*.

In accordance with 37 C.F.R. 1.97(e) the undersigned herewith states that each item of information contained in the information disclosure statement was first cited in a

communication from a foreign patent office in a counterpart foreign application not more than three months prior to the filing of the information disclosure statement.

In accordance with 37 C.F.R. 1.97 (c) (1), consideration of this Information Disclosure Statement is requested.

Respectfully submitted,



For Applicants

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Date: December 23, 2003

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